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Sheet 1 of 1 Form PTO-1449 Attorney Docket No: 740756-2351 U.S. Department of Commerce Serial No. Not Yet Assigned (Rev. 8-83) Patent and Trademark Office INFORMATION DISCLOSURE STATEMENT (Use several sheets if necessary) Applicant: Shunpei YAMAZAKI et al. Filing Date: August 21, 2001 Group: 281 U.S. PATENT DOCUMENTS Filing Date Examiner Document Number Date Name Class Subclass Initial (if appropriate) 5,612,250 03/18/1997 Ohtani et al. 5,543,352 08/06/1996 Ohtani et al. 5,895,933 04/20/1999 Zhang et al. 5,882,960 03/16/1999 Zhang et al. 6,051,453 04/18/2000 Takemura 5,953,597 09/14/1999 Kusumoto et al. 5,561,081 10/01/1996 Takenouchi et al. 5,897,799 04/27/1999 Yamazaki et al. 6,002,101 12/14/1999 Yamazaki et al. 5,968,383 10/19/1999 Yamazaki et al. 5,900,980 05/04/1999 Yamazaki et al. 6,038,075 03/14/2000 Yamazaki et al. 5,959,779 09/28/1999 Yamazaki et al. 6,002,523 12/14/1999 Tanaka FOREIGN PATENT DOCUMENTS Document Number Date Country Class Subclass Translation Yes 07-161634 06/23/1995 Japan Abstract 07-321339 12/08/1995 Japan Abstract 07-131034 05/19/1995 Japan Abstract OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.) Specification and Drawings for Patent Application Serial No. 09/610,637, "Laser Irradiation Apparatus, Laser Irradiation Method, Semiconductor Device, and Method of Manufacturing a Semiconductor Device".

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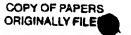
Sheet 1 Form **PTO-1449** (Rev. 8-83) epartment of Commerce Atty Docket 0756-2351 Serial No. 09/932,935 11/ Patent and Trademark Office Applicants: Shunpei YAMAZAKI et al. INFORMATION DESCL JRE STATEMENT Group Art Unit: 2812 Filing Date: August 21, 2001 **U.S. PATENT DOCUMENTS** Date Class Subclass Filing Date Examiner (if appropriate) Initial 4,599,133 07/08/1986 Miyao et al.

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Sheet 1 of 1 Form PTO-1449 U.S. Department of Commerce Attorney Docket No: 740756-2351 Serial No. Not Yet Assigned Patent and Trademark Office (Rev. 8-83) INFORMATION DISCLOSURE STATEMENT (Use several sheets if necessary) Applicant: Shunpci YAMAZAKI et al. Filing Date: August 21, 2001 Group: 2811 **U.S. PATENT DOCUMENTS** Filing Date Examiner **Document Number** Date Name Class Subclass Initial (if appropriate) 5,612,250 03/18/1997 Ohtani et al. 5,543,352 08/06/1996 Ohtani et al. 5,895,933 04/20/1999 Zhang et al. 5,882,960 03/16/1999 Zhang et al. 6,051,453 04/18/2000 Takemura 5,953,597 09/14/1999 Kusumoto et al. 5,561,081 10/01/1996 Takenouchi et al. 5,897,799 04/27/1999 Yamazaki et al. 6,002,101 12/14/1999 Yamazaki et al. 5,968,383 10/19/1999 Yamazaki et al. 05/04/1999 5,900,980 Yamazaki et al. 6,038,075 03/14/2000 Yamazaki et al. 5,959,779 09/28/1999 Yamazaki et al. 6,002,523 12/14/1999 Tanaka FOREIGN PATENT DOCUMENTS Translation Yes N Document Number Date Country Class Subclass 07-161634 06/23/1995 Japan Abstract 07-321339 12/08/1995 Japan Abstract 07-131034 05/19/1995 Japan Abstract OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.) Specification and Drawings for Patent Application Serial No. 09/610,637, "Laser Irradiation Apparatus, Laser Irradiation Method, Semiconductor Device, and Method of Manufacturing a Semiconductor Device".

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